

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Josh Eckels, *et al.*
Appln. No.: 10/784,346
Confirm. No.: 2353
Filed: February 23, 2004
Title: SYSTEMS AND METHODS FOR MULTI-VIEW
DEBUGGING ENVIRONMENT

PATENT APPLICATION

Art Unit: 2192
Examiner: Dao, Thuy Chan

Customer No. 23910

REQUEST FOR CONTINUE EXAMINATION UNDER 37 C.F.R. 1.114

Mail RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of November 20, 2007, please amend the above-identified application as followed:

Amendments to the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.